



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER OF PATENTS AND TRADEMARKS  
Washington, D.C. 20231  
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/588,478	06/07/2000	Yasuhiro Morii	50073-030	8907

20277 7590 05/22/2002

MCDERMOTT WILL & EMERY  
600 13TH STREET, N.W.  
WASHINGTON, DC 20005-3096

EXAMINER

RUDE, TIMOTHY L

ART UNIT	PAPER NUMBER
----------	--------------

2871

DATE MAILED: 05/22/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

**Office Action Summary**

Application No.

09/588,478

Applicant(s)

MORII, YASUHIRO

Examiner

Timothy L Rude

Art Unit

2871

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☐ Responsive to communication(s) filed on \_\_\_\_.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 1-16 is/are pending in the application.
- 4a) Of the above claim(s) 1-14 is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 15 and 16 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_ are subject to restriction and/or election requirement.

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on \_\_\_\_ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on \_\_\_\_ is: a) ☐ approved b) ☐ disapproved by the Examiner.  
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

**Priority under 35 U.S.C. §§ 119 and 120**

- 13) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  
a) ☐ All b) ☐ Some \* c) ☐ None of:  
1. ☐ Certified copies of the priority documents have been received.  
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_.  
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  
\* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).  
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

**Attachment(s)**

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☒ Information Disclosure Statement(s) (PTO-1449) Paper No(s) 3,6.
- 4) ☐ Interview Summary (PTO-413) Paper No(s) \_\_\_\_.
- 5) ☐ Notice of Informal Patent Application (PTO-152)
- 6) ☐ Other:

### **DETAILED ACTION**

1. Group II (claims 15 and 16) are elected for prosecution.

#### ***Claim Rejections - 35 USC § 112***

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

2. Claims 15 and 16 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite in that it fails to point out what is included or excluded by the claim language. These claims are omnibus type claims.

As to claims 15 and 16, there is the recitation "and others". Specifically, the recitation "... comprises; a step of forming a panel by sealing a first substrate having plural electrodes that include a scanning signal line, an image signal line, a pixel electrode *and others*, ..." fails to properly limit the claim as to what electrodes must be included on the first substrate. Therefore these claims are considered omnibus. Clarification of what is included or excluded in each claim is required.

#### ***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

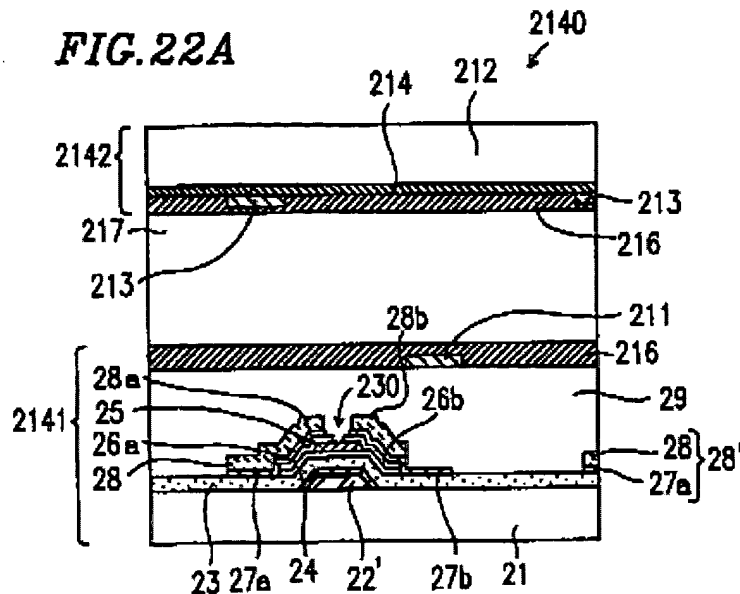
(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and

Art Unit: 2871

the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

3. Claims 15 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shimada et al (Shimada) USPAT 5,852,485, in view of Yih USPAT 3,866,313.

As to claims 15 and 16, the structural limitations in these process claims only have patentable weight when they have a non-obvious impact on the process steps, which in general, can be used to make any of a large number of LCD devices with alternate structures. Shimada discloses in Figures 21, 22A, and 22B, the process of fabricating a liquid-crystal display (LCD) device which comprises; the fabrication of LCD substrate assemblies prior to filling with liquid crystal (Example 12, col. 31, line 66 through col. 36, line 6), comprising: a step of forming a first, substrate, 21, having plural electrodes that include a source line (Applicant's scanning signal line), 28', a Gate line (Applicant's image signal line), 22, a pixel electrode, 211, and others, and an alignment layer, 216, all formed thereon, and a second substrate, 212, having a color filter, 214, a counter electrode also serving as a black matrix (Applicant's light-shielding film), 213, and an alignment layer, 216 all formed thereon.

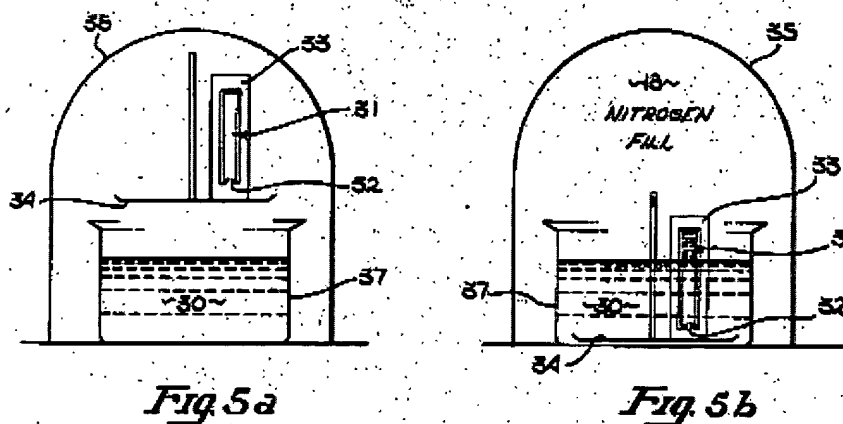


Shimada does not explicitly disclose forming a sealant between the two substrates and around the outer peripheries of the substrates in such a manner that it partly reaches the edges of the substrates to form an opening through which liquid crystal is to be injected into the space between the sealed substrates, and a step of setting the panel in a liquid crystal-injecting unit having therein a container filled with liquid crystal, evacuating both the liquid crystal-injecting unit and the panel, putting the opening of the panel into the liquid crystal in the container, thereafter restoring the liquid crystal-injecting unit to have an atmospheric pressure in that condition so that the liquid crystal is injected into the panel through its opening owing to the inner pressure difference between the unit and the panel, and finally sealing the opening of the panel in such a condition that the panel receives no external pressure.

Yih teaches in Figures 1-6 the steps of adhesive application, evacuation, filling, sealing, etc. (Figures 1-5b, and col. 2, line 41 through col. 4 line 52) comprising forming a sealant between the two substrates (col. 3, lines 20-35) and around the outer

Art Unit: 2871

peripheries of the substrates in such a manner that it partly reaches the edges of the substrates to form an opening (col. 3, lines 23-28) through which liquid crystal is to be injected into the space between the sealed substrates, and a step of setting the panel in a liquid crystal-injecting unit (col. 4, lines 10-17) having therein a container filled with liquid crystal, evacuating both the liquid crystal-injecting unit and the panel, putting the opening of the panel into the liquid crystal in the container (col. 5, lines 26-31), thereafter restoring the liquid crystal-injecting unit to have an atmospheric pressure (col. 4, lines 13-19 and col. 5, line 32 through col. 6, line 5) in that condition so that the liquid crystal is injected into the panel through its opening owing to the inner pressure difference between the unit and the panel (col. 4, lines 15-17), and finally sealing the opening of the panel in such a condition that the panel receives no external pressure (col. 4, line 19) to complete LCD assembly without bubble formation.



Yih teaches forcing the liquid crystal into the LCD assembly by replacing the partial vacuum with a non-reacting gas (therefore at atmospheric pressure) (col. 6, lines 1-3). Yih teaches sealing after removal from the vacuum which would result in the panel receiving no external pressure (col. 4, lines 18 and 19), and Yih teaches sealing *after*

Art Unit: 2871

removal of the LCD device from the liquid crystal material after filling (col. 6, lines 14-21), and that could not be accomplished without introducing a bubble (avoided by the process of Yih) if the inner pressure were any lower than atmospheric pressure, especially by as much as  $0.3 \text{ kgf/cm}^2$ .

Yih is evidence that ordinary workers in the art of liquid crystals would find the reason, suggestion, or motivation to use the adhesive application and fill techniques of Yih to complete LCD assembly with an internal pressure that is equal to atmospheric pressure to avoid bubble formation.

Therefore, it would have been obvious to one having ordinary skill in the art of liquid crystals at the time the invention was made to modify the LCD fabrication process of Shimada with the sealing and filling process steps of Yih.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Timothy L Rude whose telephone number is (703) 305-0418. The examiner can normally be reached on Monday through Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, William L Sikes can be reached on (703) 308-4842. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7724 for regular communications and (703) 308-7725 for After Final communications.


Art Unit: 2871

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 305-4900.



TLR  
April 29, 2002

Timothy L Rude  
Examiner  
Art Unit 2871

  
**TOANTON  
PRIMARY EXAMINER**